

APPENDIX CVersion with Markings to Show Changes MadeIn the Claims:

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30. A hydrogen gas detector, comprising
a light source;
a thermal energy source;
an optical filter having an optical transmissivity
responsive to the presence and concentration of
hydrogen gas in an ambient environment to which the
optical filter is exposed, said optical filter being
disposed in proximity to the light source such that
said optical filter is illuminated with light from the
light source, and being operatively coupled to the
thermal source such that the optical filter is heated
by the thermal source;
a light detector generating an output signal, the state of
said output signal being proportional to the intensity
of light impinging on the light detector, said light
detector being disposed in light-sensing relationship
to the optical filter, whereby light from the light
source passing through the optical filter impinges on

the light detector and generates said output signal as a indication of the presence and/or concentration of hydrogen gas in the ambient environment.

31. The hydrogen gas detector of claim 30, wherein the light source comprises a light-generating element selected from the group consisting of incandescent bulbs, light emitting diodes, fluorescent lamps, electroluminescent lamps, and optical lasers, and optical waveguides illuminated by any such light-generating element.
32. The hydrogen gas detector of claim 30, wherein the thermal energy source comprises a heat-generating element selected from the group consisting of incandescent bulbs, resistive wires, exothermic chemical reactions, ultrasonic radiation, acoustic radiation, microwave radiation, and laser radiation.
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35. The hydrogen gas detector of claim 30, wherein the light detector comprises a light detection element selected from the group consisting of photodiodes, avalanche photodiodes, phototubes, photomultiplier tubes, microchannel plates,

solar cells, image intensifiers, photoconductor detectors, charge-coupled devices, and combinations or arrays thereof.

36. The hydrogen gas detector of claim 30, wherein the optical filter comprises a rare earth metal thin film deposited on an optical output surface of the light source.
37. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film comprises a rare earth metal component selected from the group consisting of trivalent rare earth metals reactive with hydrogen to form both metal dihydride and metal trihydride reaction products, wherein the metal dihydride and metal trihydride reaction products have differing optical transmissivity.
38. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film comprises at least one metal selected from the group consisting of:
 - (I) scandium, yttrium, lanthanum, cerium, praseodymium, neodymium, promethium, samarium, europium, gadolinium, terbium, dysprosium, holmium, erbium, thulium, ytterbium, lutetium, actinium, thorium, protactinium, uranium, neptunium, plutonium, americium, curium, berkelium,

californium, einsteinium, fermium, mendelevium, nobelium, and lawrencium,

(II) alloys thereof, and

(III) alloys containing one or more of such metals alloyed with an alloying component selected from the group consisting of magnesium, calcium, barium, strontium, cobalt and iridium.

39. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film comprises yttrium.
40. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film is overlaid by a hydrogen-permeable material comprising a metal selected from the group consisting of Pd, Pt, Ir, Ag, Au, Ni, Co, and alloys thereof.
41. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film is overlaid in sections by a plurality of hydrogen-permeable material, each comprising a metal selected from the group consisting of Pd, Pt, Ir, Ag, Au, Ni, Co, and alloys thereof, wherein each overlay section exhibits a unique permeability to hydrogen.

42. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film is overlaid by a hydrogen-permeable material that is doped with a dopant selected from the group consisting of Mg, Ca, Al, Ir, Ni and Co.
43. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film is overlaid in sections by a plurality of hydrogen permeable materials, each of which is doped with a dopant selected from the group consisting of Mg, Ca, Al, Ir, Ni and Co, wherein each overlay section exhibits a unique permeability to hydrogen.
44. The hydrogen gas detector of claim 36, wherein the rare earth metal thin film is overlaid by a thin film of a material including a metal selected from the group consisting of palladium, platinum, and iridium.
45. A hydrogen detection system for monitoring an extended or remove area region for the incursion or generation of hydrogen therein, said hydrogen detection system comprising a multiplicity of hydrogen gas detectors as in claim 30, each of which is arranged for exposure to a specific individual locus of the extended area region.

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